

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. Filed herewith
Filing Date Filed herewith
Inventor Ji Ung Lee et al.
Assignee Micron Technology, Inc.
Group Art Unit Unknown
Examiner Unknown
Attorney's Docket No. MI30-068
Title: "Field Effect Transistor Fabrication Methods, Field Emission Device Fabrication
Methods, and Field Emission Device Operational Methods"

PRELIMINARY AMENDMENT

To: Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

EL 84 450 4097

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
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Sir:

Please enter the following amendments prior to examining the above-identified
application:

AMENDMENTS

In the Title:

Please replace the title with the following: -FIELD EFFECT TRANSISTOR
FABRICATION METHODS, FIELD EMISSION DEVICE FABRICATION METHODS,
AND FIELD EMISSION DEVICE OPERATIONAL METHODS-.